



Patents

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re Application of:

Nobuyuki YAMAUCHI et al.

Application No. 09/752,837

Filed: December 28, 2000

For: **Information Processing Apparatus
Defect Analysis Program, and Defect
Analysis Method**

Art Unit: 2114

Examiner: Le, Dieu Minh T.

Attorney Docket No.: 44471/251413

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Mail Stop Issue Fee, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on

2/17/2005

Janie Wilkins

AMENDMENT AFTER ALLOWANCE UNDER 37 CFR 1.312

Mail Stop Issue Fee
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Subject to the approval of the Examiner, please enter the following amendments.

Amendments to the Specification begin on page 2 of this paper.

Remarks begin on page 3 of this paper.